

Notice of References Cited	Application/Control No. 10/539,572	Applicant(s)/Patent Under Reexamination VIELLEROBE ET AL.	
	Examiner David N. Werner	Art Unit 2621	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Goehde, W. et al. "A Low-Temperature Scanning Confocal and Near-Field Optical Microscope". _Review of Scientific Instruments_ 68.6 (June 1997): 2466-2474.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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